



Attorney Docket No. 54008.8009.US02
P97-0041US3

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Raymon F. THOMPSON *et al.*

APPLICATION No.: 09/575,551

FILED: MAY 22, 2000

FOR: **SEMICONDUCTOR PROCESSING SYSTEM WITH
WAFER CONTAINER DOCKING AND LOADING
STATION**

EXAMINER: James W. Keenan

ART UNIT: 3652

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**AMENDMENT IN REQUEST FOR CONTINUING EXAMINATION
FOLLOWING DECISION ON APPEAL**

Introduction:

A Decision on Appeal from the final rejection of claims 56, 57, 62, 64, and 65 was mailed February 26, 2003. The new and amended claims in the present Amendment have been prepared in view of the Decision on Appeal. A Request for Continuing Examination and filing fee accompany this Amendment.

In the Claims:

Please amend claims 56 and 65 and add new claims 66-72 as shown on the attached claim sheets.

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

April 28, 2003
Date of Deposit

Debbie Gilbert
Debbie Gilbert